



Bump Bonding for Pixel Detectors

M. Campbell
EP Division
CERN

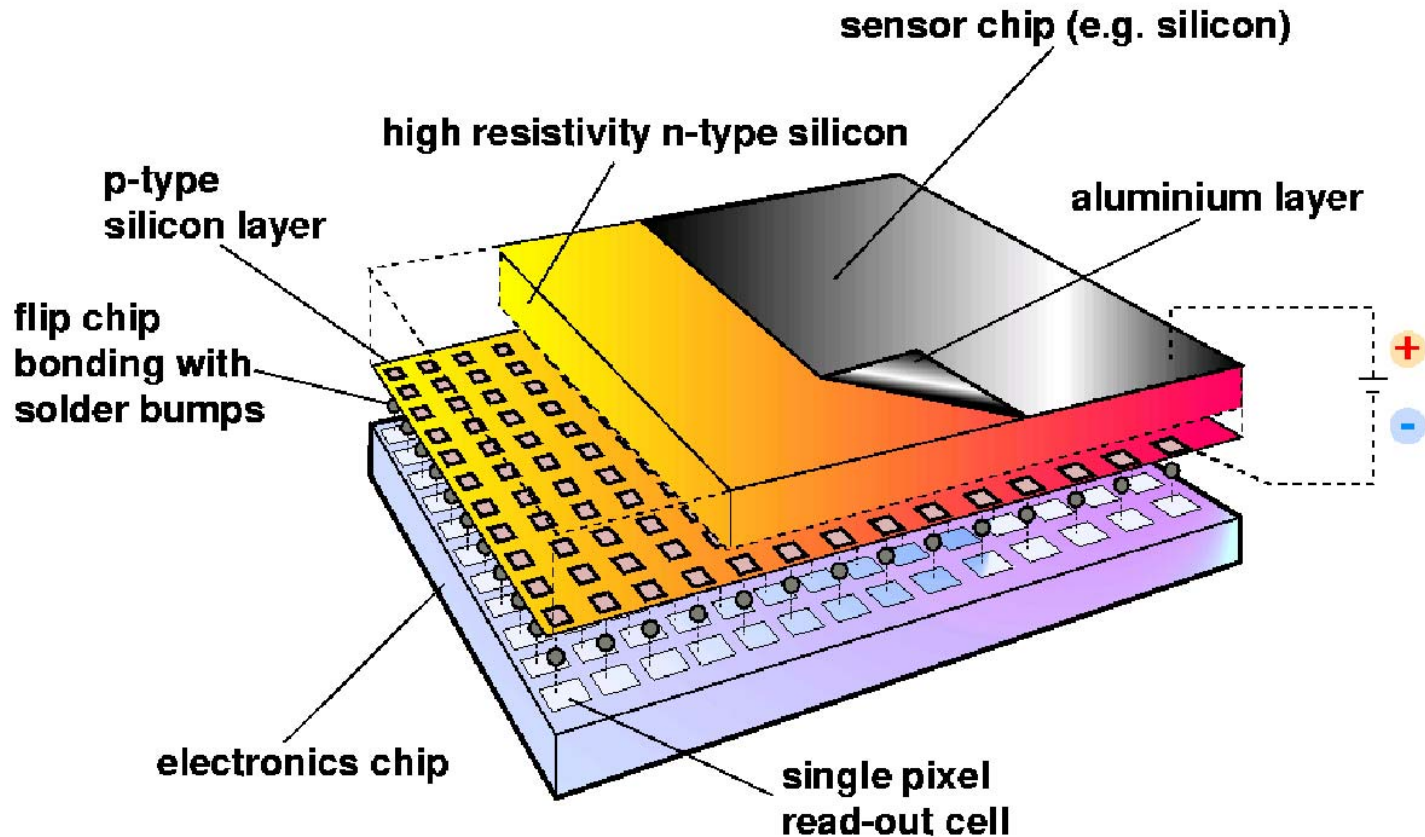


Outline

- ◆ **Introduction**
- ◆ **Applications in High Energy Physics**
- ◆ **Applications to X-ray Imaging**
- ◆ **Common Requirements**
- ◆ **Specific Requirements**
- ◆ **Accessible Companies and Technologies**
- ◆ **Comparison of Technologies**
- ◆ **Remaining Challenges for LHC**
- ◆ **Beyond LHC**



Hybrid Pixel Detector

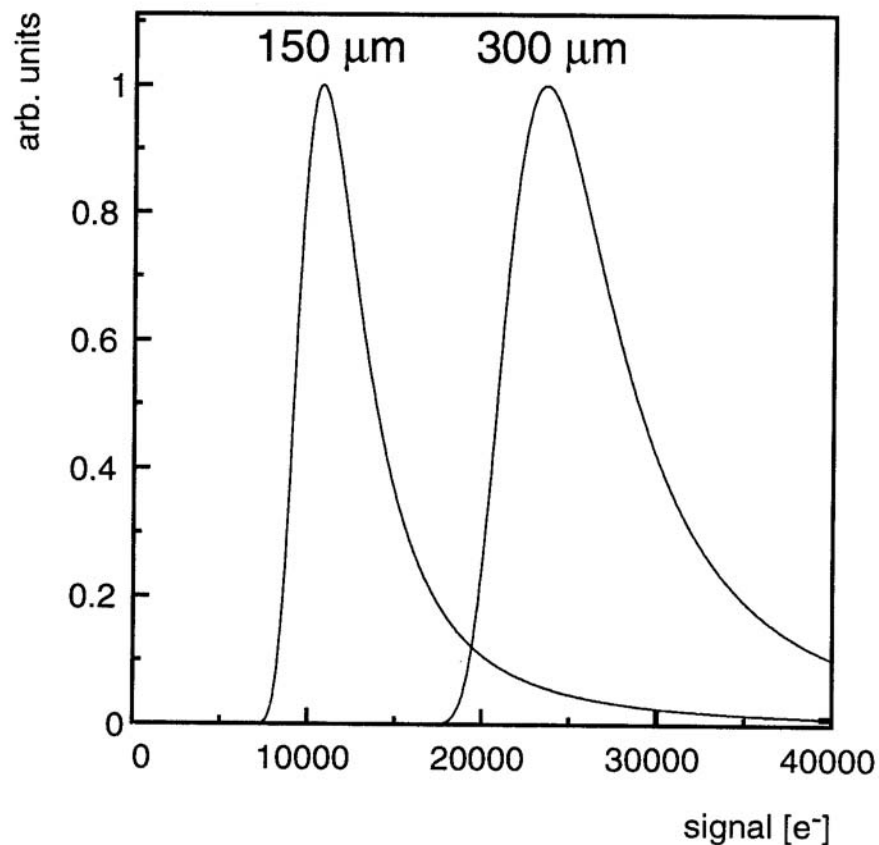


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11-12 June 2003



Landau distribution in Si detector



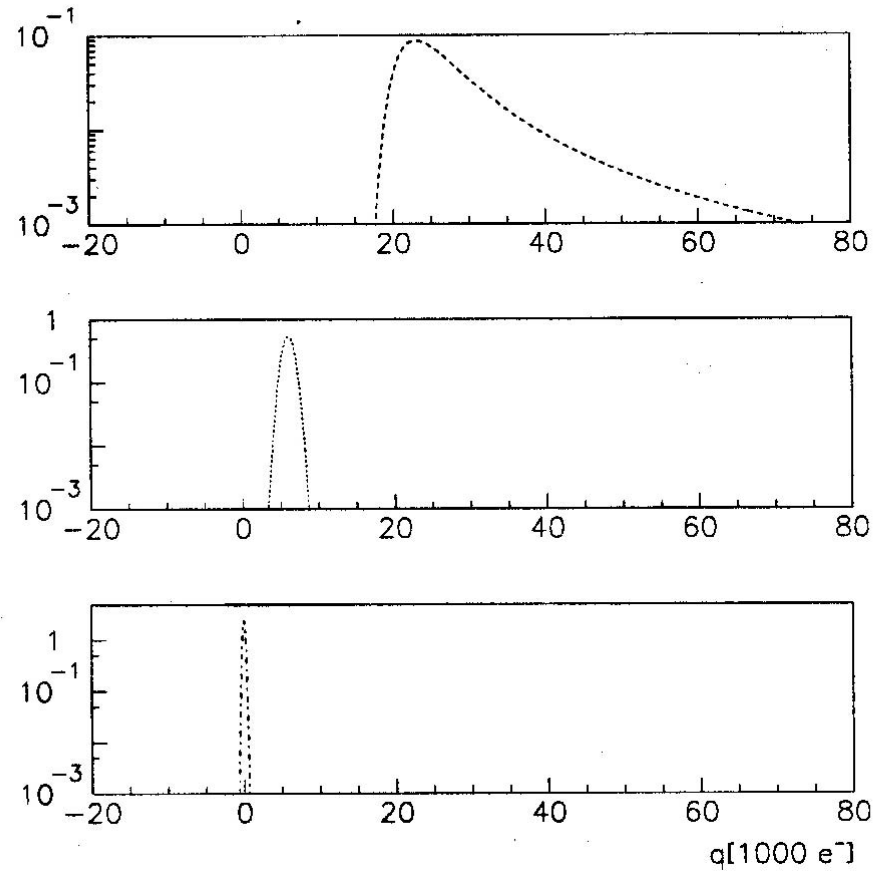
Because of charge sharing threshold normally set around 1/3rd Landau peak

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Signal, Threshold, Noise

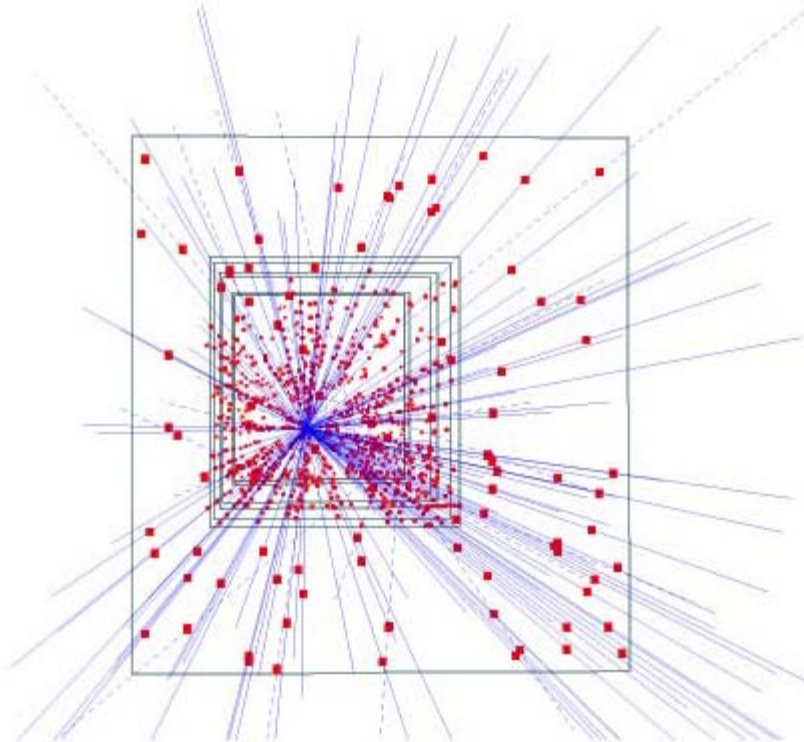


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CERN Experiment WA97 (1995)



5 x 5 cm² area
7 detector planes
Pixel dimensions 75 x 500 μm²
Trigger precision 1 μsec
1 kHz trigger rate

NB. Dead area ~3% in total
over 7 x 5 x 5 cm²



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Alice pixel detector

- ◆ **2 barrel layers**
- ◆ **p⁺ on n detectors**
- ◆ **pixel dimensions 50 μm x 425 μm**
- ◆ **chip contains 256 x 32 pixels**
- ◆ **1 x 5 chips/module**
- ◆ **~ 240 modules**
- ◆ **~ 2 million channels in total**

see talk of Petra Riedler



Atlas pixel detector

- ◆ **3 barrel layers and 3 disk layers**
- ◆ **n^+ on n detectors with p spray isolation**
- ◆ **pixel dimensions $50 \mu\text{m} \times 400 \mu\text{m}$**
- ◆ **chip contains 160×18 pixels**
- ◆ **2 x 8 chips/module**
- ◆ **$\sim 1\,500$ modules**
- ◆ **~ 100 million channels in total**



BTeV pixel detector

- ◆ **31 station 10 cm x 10 cm**
- ◆ **n^+ on n detectors with p-stop or p-spray**
- ◆ **pixel dimensions 50 μm x 400 μm**
- ◆ **chip contains 128 x 22 pixels (tentative)**
- ◆ **1 x (4 to 8) chips/module**
- ◆ **~ 30 million channels in total**



CMS pixel detector

- ◆ **3 barrel layers and 2 disk layers**
- ◆ **n^+ on n detectors with dual concentric broken p-stop rings**
- ◆ **pixel dimensions $150\ \mu\text{m} \times 150\ \mu\text{m}$**
- ◆ **chip contains 52×53 pixels**
- ◆ **2 x 8 chips/module**
- ◆ **~ 752 modules**
- ◆ **~ 33 million channels in total in barrel**

see talks of Alan Honma and Christian Brönnimann



LHCb RICH readout

- ◆ **Chip/detector assembly inside Hybrid Photon Detector (under vacuum)**
- ◆ **single photo-electron detection required (5000 e-)**
- ◆ **p⁺ on n detectors**
- ◆ **pixel dimensions 500 μm x 500 μm**
- ◆ **chip contains 32 x 32 super-pixels (each super pixel contains 8 sub pixels)**
- ◆ **~ 1000 tubes needed**
- ◆ **~ 1 million channels in total**

See talk by Thierry Gys



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Synchrotron Applications

- ◆ **PILATUS (SLS)**
 - 44 x 78 pixels, 217 μ m pitch
 - 2 x 8 chip ladders
 - see talk by Christian Brönniman

- ◆ **ALADIN (RAL)**
 - 64 x 64 pixels, 150 μ m pitch
 - 1 x 7 chip ladders

- ◆ **XPAD (Marseilles)**
 - 24 x 25 pixels, 330 μ m pitch
 - 2 x 5 chip ladders



Medical Imaging Applications

◆ Integrating systems

- Nova R&D Mary chip
 - 192 x 384 pixels, 50 μ m pitch
- AJAT DIC100
 - Xx x yy pixels, 100 μ m pitch

◆ Photon counting systems

- MPEC2.3 (Bonn) 32 x 32 pixels, 200 μ m pitch
- Medipix2 256 x 256 pixels, 55 μ m pitch



Common Requirements

- ◆ **Pitch ~ 50 μ m**
- ◆ **Chips > 1 cm²**
- ◆ **1 000 – 100 000 bumps/chip**
- ◆ **Large area coverage -> multi-chip ladders (5-16 chips per ladder)**
- ◆ **Dead area between ladders should be limited**
- ◆ **Deep sub-micron CMOS (8" wafers)**



Application Specific Requirements

- ◆ HEP
Low mass assembly
Thin Si detectors and (post bumping thinned CMOS)
Pitch limited by material budget – going $< 50\mu\text{m}$
makes no sense in present systems
- ◆ For Photo Multiplier Tube Encapsulation
Vacuum compatible technology
High temperature cycling
- ◆ X-ray imaging
High ρ (exotic!) material



Accessible Companies and Technologies

<u>Company</u>	<u>Technology</u>	<u>Experiment</u>
AMS	In (cold)	Atlas/Alice
IZM	SnPb (eutectic)	Atlas
MCNC	SbPb (eutectic)	BTeV
PSI	In (reflow)	CMS
VTT	SnPb (eutectic) SnPb (high Pb)	Alice/NA60 LHCb RICH

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Comparison of Used Technologies

<u>Technology</u>	<u>Pull Strength</u> (g/bump)	<u>Max Temp</u> (°C)
In (cold)	0.1	100
In (reflow)	0.2-0.3	250
SnPb (eutectic)	1	230
SnPb (reflow)	??	380



Typical defect and causes

- ◆ **Missing corners – poor co-planarity during alignment / reflow**
- ◆ **Low pull strength – poor UBM adhesion / poor wetting (in reflow processes)**
- ◆ **Local shorts between pixels – too much compression / movement during reflow**
- ◆ **High detector leakage currents – incomplete field layer etching / poor dicing**



Remaining challenges for the LHC

- ◆ Selection and burn-in of KGD
- ◆ Total quantities (~ 40 000 installed placements needed!)
- ◆ QA during production and feedback to suppliers
- ◆ Lifetime testing of bumps
- ◆ Handling of large numbers of extremely thin and (sometimes) fragile components
- ◆ Rework



A controversial question:

Will bump bonding problems sign the death warrant for hybrid pixel detectors in HEP ?

Depends on how we do for LHC....

Cost

Ultimately, hybrid pixels provide unbeaten pattern recognition.



Beyond LHC1

- ◆ **Solutions for single chip tiling**
- ◆ **Thinner assemblies**
- ◆ **Inter-layer interconnect**
- ◆ **True vertex finding...**

- ◆ **X-ray imaging community may become a large user too (depends on developments..)**